PATENT



Docket No. <u>1232-4609US1</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Kazuaki OHMI et al.

Serial No.:

To be assigned

Group Art Unit:

To be assigned

Filed:

June 25, 2003

Examiner:

To be assigned

For:

SEPARATING APPARATUS, SEPARATING METHOD, AND

METHOD OF MANUFACTURING SEMICONDUCTOR

SUBSTRATE

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits, please enter this Preliminary Amendment in the above-referenced application.

IN THE SPECIFICATION:

On page 1, line 6, please insert the following paragraph:

CROSS-REFERENCE TO RELATED APPLICATION

This is a divisional application under 37 C.F.R. §1.53(b) of copending US Patent Application Serial Number 09/495,847, filed on February 1, 2000, which is incorporated herein by reference in its entirety.

IN THE CLAIMS:

Please cancel claims 1-19 without prejudice or disclaimer.